

EXHIBIT G

03/16/02
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Docket No.: M-12245 US

J1017 U.S. PTO
10/101863
03/16/02

March 16, 2002

Box Patent Application
Commissioner For Patents
Washington, D. C. 20231

Enclosed herewith for filing is a patent application, as follows:

Inventor(s): Zhang, Hongmei; Narasimhan, Mukundan; Mullapudi, Ravi; and Demaray, Richard E.

Title: **Biased Pulse DC Reactive Sputtering of Oxide Films**

- X Return Receipt Postcard
- X This Transmittal Letter (in duplicate)
- 2 page(s) Declaration For Patent Application and Power of Attorney (unsigned)
- 34 page(s) Specification (not including claims)
- 4 page(s) Claims
- 1 page Abstract
- 27 Sheet(s) of Drawings

Applicant(s) assert(s) entitlement to small entity status for the attached patent application

CLAIMS AS FILED (fees computed under 37 CFR §1.9(f))

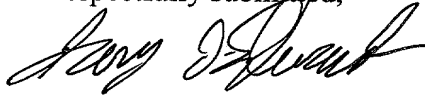
For	Number Filed		Number Extra		Rate		Basic Fee
Total Claims	39	-20 =	9	x	\$ 9.00 =		\$ 81.00
Independent Claims	5	-3 =	2	x	\$42.00 =		\$ 84.00
<input type="checkbox"/> Fee of _____ for the first filing of one or more multiple dependent claims per application							\$
<input type="checkbox"/> Fee for Request for Extension of Time							\$

Please make the following charges to Deposit Account 19-2386:

- Total fee for filing the patent application in the amount of \$ 525.00
- The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account 19-2386.

EXPRESS MAIL LABEL NO:
EL 941 069 152 US

Respectfully submitted,



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